



Whereby certify that this correspondence is being deposited with the united states postal service as in an envelope addressed to:  
Commissioner of patents and trademarks, Washington, D.C. 20231, on 7/29/03. The applicant and/or attorney requests the date  
of deposit as the filing date. Depositor: KAREN CINO-MARS

Karen Cino-Mars 7/29/03  
(Signature & date)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of \_\_\_\_\_: 7/29/03

Wei Lu, et al. Group Art Unit:

Serial No. 10/604,110: Examiner:

Filed: 6/26/03

International Business  
Machines Corporation  
2070 Route 52  
Hopewell Junction, NY 12533

**TITLE: METROLOGY PROCESS FOR ENHANCING IMAGE CONTRAST**

**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit copies of the prior patents and publications as listed on Form PTO-1449, attached hereto.

In citing these documents, no representation is made nor intended as to the pertinency or non-pertinency of the art, that better art than that listed is not available, or that other art is not applicable.

Respectfully submitted,  
Wei Lu, et al.

By Tiffany L. Townsend  
Tiffany L. Townsend, Attorney  
Registration No. 43,199  
Telephone No. 845-894-3668

**INFORMATION DISCLOSURE CITATION***(Use several sheets if necessary)*

Docket Number (Optional)

**FIS920030143US1**

Application Number

Applicant(s)

**WEI LU, ET AL.**

Filing Date

**6/26/03**

Group Art Unit

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		2002/0195422A1	12/26/02	SIEVERS, ET AL.			
		2002/0019137A1	2/14/02	TSUNG, ET AL.			

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

**OTHER DOCUMENTS** *(Including Author, Title, Date, Pertinent Pages, Etc.)*


**EXAMINER****DATE CONSIDERED**

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.